



Attorney Docket No. 0756-7223

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ENTERED  
BY RCE  
10/30/06  
RCE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/721,075

Filed: November 26, 2003

For: LASER IRRADIATION APPARATUS,

LASER IRRADIATION METHOD,

AND METHOD FOR

MANUFACTURING A

SEMICONDUCTOR DEVICE

) Group Art Unit: 1725

) Examiner: Maria A. Elve

) CERTIFICATE OF MAILING

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) Alexandria, VA 22313-1450, on September  
) 28, 2006.

) Ashley M. Stamps

**AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated June 28, 2006, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Specification begin on page 2 of this paper.**

**Remarks begin on page 3 of this paper.**